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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hajime YAMAMOTO et al.**

Art Unit: **1795**

Application Number: **10/647,247**

Examiner: **Daborah Chacko Davis**

Filed: **August 26, 2003**

Confirmation Number: **1773**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND  
METHOD OF FORMING RESIST PATTERN**

Attorney Docket Number: **031029**  
Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 29, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 1, 2008 for two months from July 1, 2008 to September 1, 2008.

Attached please find a check in the amount of \$460 for the cost of the extension of time.

If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

A handwritten signature in black ink.

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AGM/klf